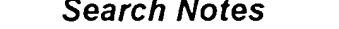


Search Notes 	Application/Control No. 10/646,161	Applicant(s)/Patent under Reexamination SAWYER, MICHAEL D.
	Examiner Hai C. Pham	Art Unit 2861

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner